

Notice of References Cited		Application/Control No. 10/757,387	Applicant(s)/Patent Under Reexamination ONO, KAZUYUKI	
		Examiner Michael Maskell	Art Unit 2809	Page 1 of 2

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,040,431 A	08-1991	Sakino et al.	74/490.09
*	B	US-5,523,843 A	06-1996	Yamane et al.	356/500
*	C	US-5,684,856 A	11-1997	Itoh et al.	378/34
*	D	US-5,858,587 A	01-1999	Yamane et al.	430/22
*	E	US-5,864,389 A	01-1999	Osanai et al.	355/53
*	F	US-5,886,432 A	03-1999	Markle, David A.	310/12
*	G	US-5,925,956 A	07-1999	Ohzeki, Hisao	310/90.5
*	H	US-6,040,675 A	03-2000	Ono, Kazuya	318/649
*	I	US-6,072,183 A	06-2000	Itoh et al.	250/492.2
*	J	US-6,259,174 B1	07-2001	Ono, Kazuya	310/13
*	K	US-6,281,655 B1	08-2001	Poon et al.	318/649
*	L	US-2002/0140298 A1	10-2002	Maruyama, Hiroyuki	310/54
*	M	US-6,639,333 B1	10-2003	Kamata et al.	310/12

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	EP 1143492 A1	10-2001	European Patent	TAKAHASHI et al.	H01L 21/027
	O	EP 1143492 A1	10-2001	European Patent	TAKAHASHI et al.	H01L 21/027
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Won-Jong, et al. "High-precision magnetic levitation stage for photolithography," Precision Engineering, 22:66-77, 1998
	V	Chen, et al. "Design and control for an electromagnetically driven x-y-theta stage," Precision Engineering, 26 (2002) 355-369
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.

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		10/757,387	ONO, KAZUYUKI	
Examiner		Art Unit	Michael Maskell	
		2809	Page 2 of 2	

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-6,717,159 B2	04-2004	Novak, W. Thomas	250/492.2
*	B	US-6,770,890 B2	08-2004	Tanaka, Keiichi	250/442.11
*	C	US-7,139,065 B2	11-2006	Ono, Kazuyuki	355/72
	D	US-			
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

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